

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

TOSHIHISA NOZAWA, *et al.*

Serial No.: 10/585,408

Filed: July 7, 2006

For: SUBSTRATE PROCESSING APPARATUS

**Confirmation No. 2529**

Art Unit: 1792

Examiner: Keath T. CHEN

Atty. Dckt: 033082 M 335

**RESPONSE UNDER 37 C.F.R. 1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**Mail Stop: AF**

Dear Sir:

This is in response to the Office Action mailed December 23, 2008, to which the time for response was set to expire March 23, 2009. A Petition for an Extension of Time and the requisite fee are submitted herewith to extend the date for response to June 23, 2009. The pending claims, claims 2-5, 8 and 10, were rejected. Reconsideration and entry of the following amendments are respectfully requested.

Amendment to the Claims begins on page 2 of this paper.

Remarks begin on page 4 of this paper.